

<b>Notice of References Cited</b>	Application/Control No. 10/599,989		Applicant(s)/Patent Under Reexamination VAN DER WEIDE ET AL.	
	Examiner Jean B. Corrielus		Art Unit 2611	Page 1 of 1

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*	B	US-2003/0108133	06-2003	Richards, James L.	375/351
*	C	US-2004/0017861	01-2004	Kobayashi et al.	375/317
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	M	US-			

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**NON-PATENT DOCUMENTS**

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